

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application:

Application No.:

Filed:

Title:

Commissioner for Patents
Washington, D.C. 20231

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST
(REVOCATION OF PRIOR POWERS)

As assignee of record of each of the patent applications listed in the table of attachment A,

REVOCATION OF PRIOR POWERS OF ATTORNEY

all powers of attorney previously given in each of the listed patent applications are hereby revoked, and

NEW POWER OF ATTORNEY

the following attorneys/agents are hereby appointed to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith: I hereby appoint all attorneys of Thomas, Kayden, Horstemeyer & Risley, LLP, who are listed under the USPTO Customer Number shown below as the attorneys to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith, recognizing that the specific attorneys listed under that Customer Number may be changed from time to time at the sole discretion of Thomas, Kayden, Horstemeyer & Risley, LLP, and request that all correspondence about the application be addressed to the address filed under the same USPTO Customer Number.

000047390

Patent Trademark Office

Please direct all future correspondence and telephone calls to:

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ASSIGNEE OF ENTIRE INTEREST

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ASSIGNEE CERTIFICATION

The certification under 37 C.F.R. §3.73(b) establishing the right of assignee to take action is attached hereto along with documentation evidencing same. Further, in my official position with Taiwan Semiconductor Manufacturing Company, Ltd., I am authorized to sign documents and otherwise act on its behalf in connection with the management and handling of patent applications and other intellectual property matters.

Date: December 27, 2004



Chien-Wei (Chris) Chou
Director - Intellectual Property Division

Attachment A

No.	Serial No	TSMC No.	Application Title	Filing Date	Assignment (Reel/Frame)
1	10/657,503	2002-0544	Phase Shift Assignments for Alternate PSM	9/8/03	014479/0625
2	10/425,322	2002-0382	Quartz Damage Repair Method for High-End Mask	4/29/03	014025/0791
3	10/661,746	2002-0353	Method to Shrink Cell Size in a Split Gate Flash	9/12/03	014500/0769
4	10/796,891	2002-0254B	Storage Element and SRAM Cell Structures Using Vertical FETS Controlled by Adjacent Junction Bias Through Shallow Trench Isolation	3/9/04	Recorded 014006/0344 at the parent application USP6,759,699
5	10/689,431	2002-0218	Method for Measuring Capacitance-Voltage Curves for Transistors	10/20/03	014622/0410
6	10/714,998	2002-0212	Water Soluble Negative Tone Photoresist	11/17/03	014712/0284
7	10/796,430	2002-0189	Placement and Routing Method to Reduce Joule Heating	3/9/04	015069/0548
8	10/307,646	2002-0132	Scheme for Eliminating the Channel Unexpected Turn-On During BSD Zapping	12/2/02	013547/0654
9	10/388,274	2002-0127	Light Guide for Image Sensor	3/12/03	013876/0368
10	10/256,401	2002-0064	Complementary Replacement of Material	9/27/02	013351/0995
11	10/788,175	2002-0047	Method for Making Improved Bottom Electrodes for Metal-Insulator-Metal Crown Capacitors	2/26/04	015033/0280
12	10/723,237	2001-1630	Method to Form a Robust TiCl ₄ Based CVD TiN Film	11/26/03	
13	10/755,500	2001-1596	Single Trench Repair Method with Etched Quartz for Attenuated Phase Shifting Mask	1/12/04	014896/0968
14	10/205,790	2001-1582	Full Sized Scattering Bar Alt-PSM Technique for IC Manufacturing in Sub-Resolution ERA	7/26/02	013148/0435

15	10/781,182	2001-1582D	Full Sized Scattering Bar Alt-PSM Technique for IC Manufacturing in Sub-Resolution ERA	2/18/04	Recorded 013148/0435 at the parent application USP6,711,732
16	10/781,176	2001-1582B	Full Sized Scattering Bar Alt-PSM Technique for IC Manufacturing in Sub-Resolution ERA	2/18/04	Recorded 013148/0435 at the parent application USP6,711,732
17	10/782,670	2001-1582E	Full Sized Scattering Bar Alt-PSM Technique for IC Manufacturing in Sub-Resolution ERA	2/19/04	Recorded 013148/0435 at the parent application USP6,711,732
18	10/680,577	2001-1701B	SRAM Cell Design for Soft Error Rate Immunity	10/7/03	Recorded 013408/0285 at the parent application USP6,649,456
19	10/682,269	2002-0026B	Asymmetrical Reset Transistor with Double-Diffused Source for CMOS Image Sensor	10/9/03	Recorded 013422/0370 at the parent application USP6,642,076

Date: December 27, 2004



Chien-Wei (Chris) Chou
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